

REMARKS

Present Status of the Application

The drawing is objected because the legend "Prior Art" is required to add in Fig. 1. The specification is objected because page 24 should be deleted. Claim 5 is objected because typographic errors are founded. The Office Action allowed claim 1-25, but the Office Action rejected claims 26 and objected claims 27-30. Specifically, the Office Action rejected claim 26 under 35 U.S.C. 103(a), as unpatentable over Yee (US 5872976) in view of Prior Art Admitted by the Applicant. Applicants have amended Fig. 1 and claim 5, and deleted page 24 to overcome the objection. Applicants have amended claim 26 to overcome the rejection.

Discussion of Office Action Objections and Rejections

The Office Action objected the drawing, the specification and claim 5. Applicants have added the legend "Prior Art" in Fig. 1, and deleted page 24 to overcome the objections. Applicants also have amended " worker's " to -- worker's -- in claim 5 to overcome the objection. Claim 26 has been amended, and thus overcoming the objection about "node."

Applicants respectfully traverse the rejection of claim 26 under 103(a) as being unpatentable over Yee (US 5872976) in view of Prior Art Admitted by the Applicant because a prima facie case of obviousness has not been established by the Office Action.

With respect to claim 26, independent claim 26 recites the features as follows:

26 A lithography rework analysis system, comprising:
a machine room having a plurality of machine groups undergo a serious of operations;
a network server for linking with a network database, ***wherein the network database is linked with the machine groups for storing comprising initial data and batches of rework data of the machine groups, and the network server processes data stored in the network database;***
and
a user computer having a browser interface for inputting an analysis time node and displaying data retrieved by from the network server from the network database according to the analysis time node.

In Yee's reference, a network system including a server 10 having a database 16 and individual nodes 14 is disclosed (Fig 1, col. 3, lines 48-58). However, Yee's system lacks a machine room having a plurality of machine groups. Moreover, Yee does not teach that the network database is linked with the machine groups for storing comprising initial data and batches of rework data of the machine groups, and the network server processes data stored in the network database. The Office Action points out that Yee does not disclose the network database includes batches rework data, but applicants admitted that a database including batches of network production data is generally known in a manufacturing system (in par. [0006]). However, since the database including batches of network production data described in admitted prior art is not linked with a network server, the data obtained from the database is unprocessed and unanalyzed raw data. In claim 26 of this application, the network database is linked with a network server, and the network server processes the data that stored in the network database. Hence, when inputting an analysis time node form a user computer, a required data retrieved by from the network server from the network database according to the analysis time node can be

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obtained. Therefore, claim 26 is not disclosed by Yee in view of Prior Art Admitted by the Applicant.

For at least the foregoing reasons, Applicant respectfully submits that independent claim 26 patently define over the prior art reference, and should be allowed. For at least the same reasons, dependent claims 27-30 patently define over the prior art as well.

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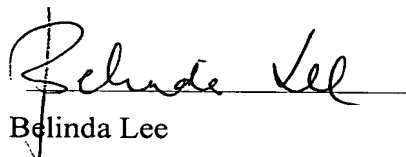
CONCLUSION

For at least the foregoing reasons, it is believed that the pending claims 26-30 are in proper condition for allowance. If the Examiner believes that a telephone conference would expedite the examination of the above-identified patent application, the Examiner is invited to call the undersigned.

Respectfully submitted,

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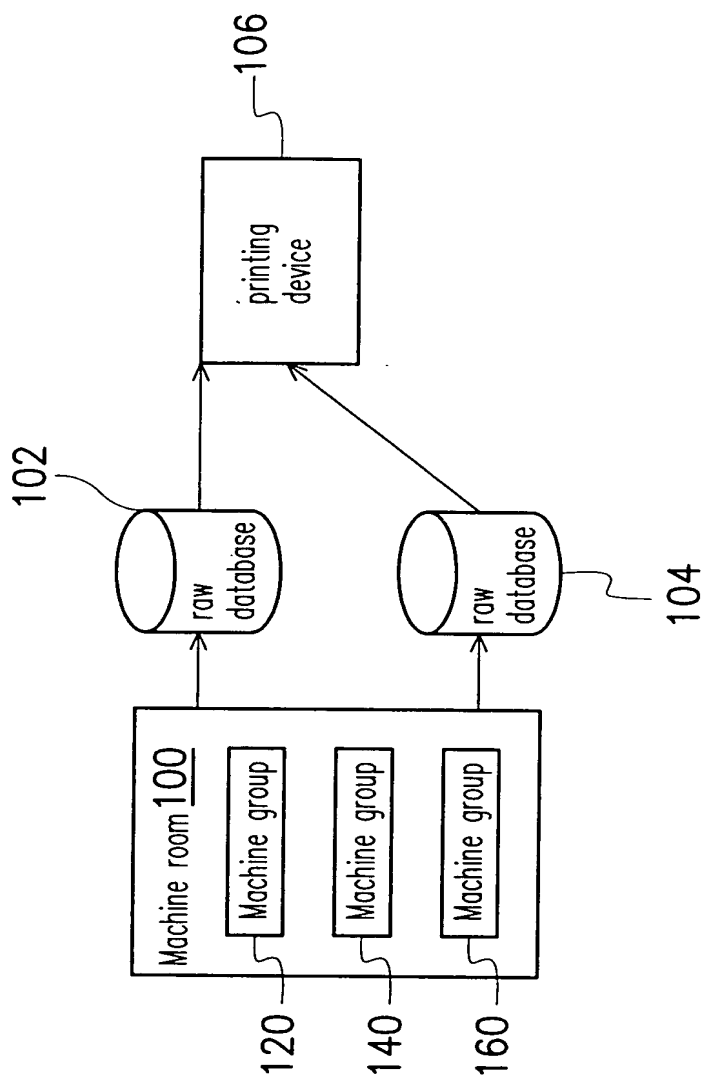


FIG. 1 (Prior Art)

